Se	arch	Notes	;

Application/Control No.	Applicant(s)/Patent under Reexamination	Applicant(s)/Patent under Reexamination	
10/694,094	CHU, CHI-JUNG	CHU, CHI-JUNG	
Examiner	Art Unit	Art Unit	
Elizabeth A. Rielley	2879	2879	

SEARCHED			
Class	Subclass	Date	Examiner

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
	l		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
See attached search history.	8/26/2005	ER	